Search Notes

Application/Control No.	Applicant(s)/Patent under Reexamination	
10/532,048	OTOMARU ET AL.	
Examiner	Art Unit	
Caixia Lu	1713	

SEARCHED							
Class	Subclass	Date	Examiner				
556 502	57x	5-24-07	ch				
502	171						
1	190						
	140						
	132						
506	133						
	1617						
	169*		•				
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INTERFERENCE SEARCHED							
Class	Subclass	Date	Examiner				
556	21,57	5/24/07	ca				
50,2	103,140						
	132,171						
516	133, 161						
	169						

SEARCH NOTES (INCLUDING SEARCH STRATEGY)				
	DATE	EXMR		
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